

## **GMReis Granted US Patent on MIRO Guide for Mica Procedure**

April 16, 2024

GMReis is granted US Patent No 2024/0041478 A1, Guide Device for Bone Correction Procedure and Bone Correction Method.

In cooperation with Dr. Gustavo Araujo, the company has developed a device that will help surgeons more accurately perform its MIS Foot - MICA procedure using the MIRO single-use guide to control rotation correction of the first metatarsal head in hallux valgus correction.

Features of MIRO include:

- MIRO Distractor which adjusts the length of the guide to the patient's anatomy
- Radiolucent MIRO tips that allow visualization of correction on intraoperative images
- Controlled rotation correction options: 10°, 20° and 30°
- An accurate and reproducible technique

GMReis offers a comprehensive portfolio of solutions for MIS foot procedures, including osteotomy burrs, arthrodesis burrs, beveled screws and the MIRO guide.

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